

FORM SB08* INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)	Docket Number: 14434.0112USWO	Application Number: 10/590105
	Applicant: IWAMURA	
	Filing Date: August 22, 2006	Group Art Unit: 1712

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Patsalas, et al., Polycrystalline diamond formation by post-growth ion bombardment of sputter-deposited amorphous carbon films", Carbon, vol. 37, pp. 865-869, 1999					
		Patsalas, et al., "Crystallization effects and diamond formation in amorphous carbon films under low energy ion beam irradiation", Nuclear Instruments and Methods in Physics Research Section B: Beam Interactions with Materials and Atoms, vol. 178, issues 1-4, pp. 247-251, 2001					

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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	